



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takashi HIRAGA et al.

Group Art Unit: 1774

Application No.: 09/913,315

Examiner: J. GRAY

Filed: August 10, 2001

Docket No.: 110345

For: MODIFICATION METHOD OF SURFACE LAYER AND MOLDED RESIN  
ARTICLE, AND MODIFICATION APPARATUS OF SURFACE LAYER OF  
MOLDED RESIN ARTICLE

**REQUEST FOR PERSONAL INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants hereby request a personal interview with the Examiner assigned to the above-identified application in order to develop and clarify specific issues raised in the April 20, 2005, Office Action, and addressed in the September 19 Amendment, in order to reach a mutual understanding between the Examiner and the Applicants, and thereby advance the prosecution of the application. The Examiner is requested to contact Applicants' representatives at the number listed below in order to schedule the personal interview.

Respectfully submitted,

  
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Registration No. 27,075

Philip A. Caramanica, Jr.  
Registration No. 51,528

JAO:PAC/brc

Date: September 20, 2005

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